



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al.

Art Unit : 2829

Serial No. : 09/917,095

Examiner : Evan T. Pert

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Notice of Allowance Date: October 30, 2003

Title : PLASMA CVD METHOD

MAIL STOP ISSUE FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE
PURSUANT TO 37 C.F.R. §1.312

Please amend the application as indicated on the following pages. This amendment is being filed concurrently with the payment of the issue fee.

Amendments to the Specification begin at page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.